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PATENT APPLICATION

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shinichi SHIMA) : Examiner: H. Nguyen
Application No.: 09/986,958 ✓) : Group Art Unit: 2851
Filed: November 13, 2001) : Confirmation No.: 6387
For: EXPOSURE APPARATUS, METHOD OF) : Issue Fee Paid: July 28, 2004
MANUFACTURING SEMICONDUCTOR) : September 9, 2004
DEVICES, SEMICONDUCTOR)
MANUFACTURING PLANT, METHOD OF)
MAINTAINING EXPOSURE APPARATUS, AND)
POSITION DETECTOR)

Mail Stop Issue Fee

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

ATTENTION: Office of Patent Publication/Publishing Division

RESPONSE TO NOTICE OF DRAWING
INCONSISTENCY WITH SPECIFICATION

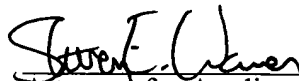
Sir:

In response to the NOTICE OF INCONSISTENCY WITH SPECIFICATION mailed August 12, 2004, enclosed is a substitute page 18 to be substituted for page 18 of the substitute specification currently on file. Substitute page 18 corrects the defect noted in the Notice. Specifically, the description of Fig. 10C, inadvertently omitted, has been returned to the specification in its appropriate place. Also enclosed is a copy of the NOTICE OF DRAWING INCONSISTENCY WITH SPECIFICATION.

The Commissioner is authorized to charge any fees for filing this paper to Deposit Account No. 06-1205. A duplicate of this paper is attached for that purpose.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Steven E. Warner", is written over a horizontal line.

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